

N/FCC DPW

Attorney's Docket No.: P18237

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Patent Application of:

Michael D. Goodner et al.

Application No.: 10/829,592

Filed: April 21, 2004

Title: PHOTSENSITIVE DIELECTRIC
LAYER

Examiner: Curley, Lynne Anne

Art Unit: 2812

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22131-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

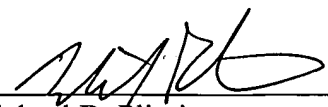
This Information Disclosure Statement is being submitted under 37 C.F.R. §1.97(b)(2). Enclosed is a copy of Information Disclosure Citation Form PTO-1449 together with a copy of the patents cited on that form. It is respectfully requested that the cited patents be considered and that the enclosed copy of Information Disclosure Citation Form PTO-1449 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s).

Pursuant to 37 C.F.R. § 1.97, the submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made and is not to be construed as an admission that the information cited in this statement is material to patentability.

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Respectfully submitted,

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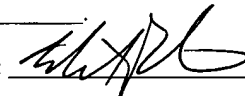
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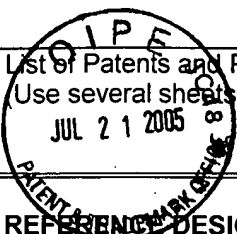
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Form PTO-1449 (Modified)		Atty Docket No.: P18237		Serial No.: 10/829,592			
<div style="float: left; width: 150px; text-align: center;">  </div> List of Patents and Publications Statement (Use several sheets if necessary)				Applicant: Michael D. Goodner et al.			
				Filing Date: April 21, 2004			
REFERENCE DESIGNATION			U.S. PATENT DOCUMENTS				
Examiner Initials		Document No.		Class	Sub-Class	Filing date if appropriate	
	AA	6,252,290 B1	Quek et al.	257	522		
	AB	6,833,320 B2	Meagley et al.	438	640		
	AC	2002/0175417 A1	Morrow et al.	257	758		
	AD	2002/0158337 A1	Babich et al.	257	758		
	AE						
	AF						
	AG						
	AH						
FOREIGN PATENT DOCUMENTS							
No.		Document No.	Date	Country	Class	Sub-Class	Translation
	AI	102 38 024 A1	3/11/2004	Germany	H01L	21/768	
	AJ						
	AK						
OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)							
	AL	Robert P. Meagley et al., "Photodefinable Polymers for Semiconductor Applications", Serial No. 10/337,575, Filed January 6, 2003.					
	AM	Robert P. Meagley et al., "Photodefinable Polymers for Semiconductor Applications", Serial No. 10/616,895, Filed July 10, 2003.					
	AN	Andrew W. Ott et al., "Forming a Dielectric Layer Using Porogens", Serial No. 10/394,104, Filed March 21, 2003.					
	AO	Grant M. Kloster et al., "Forming a Porous Dielectric Layer", Serial No. 10/395,447, Filed March 24, 2003.					
	AP	Grant M. Kloster et al., "Forming a Porous Dielectric Layer", Serial No. 10/782,329, Filed February 19, 2004.					
	AQ	Michael D. Goodner, "UV-Activated Dielectric Layer", Serial No. 10/403,532, Filed March 31, 2003.					
	AR	Michael D. Goodner, "UV-Activated Dielectric Layer", Serial No. 11/058,798, Filed February 15, 2005.					
	AS	Robert P. Meagley et al., "Photoactive Resist Capping Layer", Serial No. 10/927,885, Filed August 27, 2004.					
	AT	Robert P. Meagley et al., "Removing Sacrificial Material by Thermal Decomposition", Serial No. 10/953,744, Filed September 29, 2004.					
	AU	Vijayakumar S. RamachandraRao et al., "Post-Deposition Modification of Interlayer Dielectrics, Serial No. 10/609,963, Filed June 30, 2003.					
	AV	Robert P. Meagley, "Photoactive Adhesion Promoter", Serial No. 10/288,021, Filed November 4, 2002.					
	AW						
Examiner			Date Considered				
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							